

Annexure 1A

Status of Equipments, Tools & Machinery

Name of the Faculty & Department: **Centre for Nanoscience and Nanotechnology**

| S. No. | Name of the Equipment/Tool/Machinery | Cost (Rs.) | Date of Purchase | Utilization Ratio in % | Remarks |
|---------------|--|-------------------|-------------------------|-------------------------------|--|
| 1. | Scanning Probe Microscope (SPM) | US \$1,37,250 | 24/11/2012 | 100 % | Department of Information Technology Project |
| 2. | Plasma Enhanced Chemical Vapor Deposition (PECVD) System | US \$2,40,000 | 30/11/2012 | 100 % | -Do- |
| 3. | Gold Coating Unit | 8,22,116 | 07/07/2011 | 100 % | -Do- |